

# INFORMATION DISCLOSURE CITATION

(Use several sheets if necessary)

Express Mail Number EV342470635US

Docket Number (Optional)

100-23700 (P05749)

Application Number

New

Applicant(s)

Peter J. Hopper et al.

Filing Date

Herewith

Group Art Unit

Unknown

## U.S. PATENT DOCUMENTS

*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
<u>DL</u>		U.S. Appln. 10/290,138		Padmanabhan et al.			11/06/02
		6,440,801 B1	08/27/02	Furukawa et al.	438	272	06/28/00
		5,578,850	11/26/96	Fitch et al.	257	329	01/16/96
		4,871,684	10/03/89	Glang et al.	437	31	10/29/87
		6,504,210 B1	01/07/03	Divakaruni et al.	257	344	06/23/00
		5,963,800	10/05/99	Augusto	438	212	06/17/96
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		5,627,395	05/06/97	Witek et al.	257	350	11/02/95
<u>DL</u>		4,750,023	06/07/88	Shannon	357	23.3	06/05/87

## FOREIGN PATENT DOCUMENTS

	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
							YES	NO

## OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

<u>DL</u>	H. Pein and James D. Plummer, "Performance of the 3-D PENCIL Flash EPROM Cell and Memory Array", IEEE Transactions on Electron Devices, Volume 42, No. 11, 1995, pp. 1982-1991.
<u>DL</u>	H. Pein and James D. Plummer, "A 3-D Sidewall Flash EPROM Cell and Memory Array", Electron Device Letters, Volume 14, (8), 1993, pps. 415-417.

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[Signature]

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4/4/05

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
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PR		U. Simu et al., "Limits in Micro Replication of CVD Diamond By Moulding Technique", 1997, [online], [retrieved on 2003-11-16]. Retrieved from the Internet: <URL:http://www.angstrom.uu.se/solidstatephysics/joakim/limits.pdf>. pp. 1-11, (note page 5, column 2, lines 15-23).
PR		E. Hui et al., "Carbonized Parylene as a Conformal Sacrificial Layer", [online], [retrieved on 2003-11-16]. Retrieved from the Internet: <URL:http://www.bsac.eecs.berkeley.edu/archive/users/hvi-elliott/pdf/sacpaper.pdf>. pp 1-5 (unnumbered), (note page 2, Process Characterization, first paragraph).

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G. Stemme, "Fabrication of MEMS", [online], [retrieved on 2003-11-16], Retrieved from the Internet:  
<URL: <http://mmadou.eng.vci.edu/PDF%20Files/Stemme%20Fabrication.pdf>>. pp. 1-9 (unnumbered), (note page 3.)

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